Docket No.: 60188-550 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Nobuaki TARUMI, et al.

Serial No.: : Group Art Unit:

Filed: July 07, 2003 : Examiner:

For: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Serial No.:

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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Date: July 7, 2003

SHEET 1 OF 1

INFORMATION DISCLOSURE CITATION IN AN APPLICATION				ATTY. DOCKET NO. 60188-550	SE	SERIAL NO.		
				APPLICANT Nobuaki TARUMI, et al.				
(PTO-1449)				FILING DATE July 07, 2003	GROUP			
U.S. PATENT DOCUMENTS								
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code2 (# known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document		Page	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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EXAMINER'S	<u> </u>	Foreign Patent Document	Publication Date	Name of Patentee or	Pages, Colu	1. C.		anslation
INITIALS	CITE NO.	Country Codes -Number 4 -Kind Codes (if known)	MM-DD-YYYY	Applicant of Cited Document	Where Relevant Figures Appear			
							Yes	No
		JP 2001-284449	10/12/2001	YAMAGISHI, et al.		·	abstract	
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1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.